

<b>Notice of References Cited</b>	Application/Control No. 10/052,071	Applicant(s)/Patent Under Reexamination REDDY ET AL.	
	Examiner Chih-Ching Chow	Art Unit 2122	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,684,386	01-2004	Baisley, Donald Edward	717/114
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Metamodeling in OO" OOPSLA '95 Workshop summary, by Hamed Mili, Francois Pachet, Ilham Benyahia, Fred Eddy. OOPSLA'95, October 15-19, 1995, pages 105 -110.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.